

Examiner Initials*	Cite No. ¹	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
		Number	Kind Code ² (if known)		
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MD		US 4/517,217		05/14/85	Hoffman
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DD		Misaki H. et al., "Hydrogen-Containing SiCN Protective Films For Magneto-Optical Media", vol. 25, NR. 5, Pags 4030-4032, XP000069274	
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